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Docket No.: M4065.0278/P278
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kevin L. Beaman et al.

Application No.: 09/653,281

Confirmation No.: 4745

Filed: August 31, 2000

Art Unit: 2812

For: USE OF ATOMIC OXIDATION FOR
FABRICATING OF OXIDE-NITRIDE-OXIDE
STACK FOR FLASH MEMORY DEVICES

Examiner: R. A. Booth

REQUEST FOR RECONSIDERATION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated November 2, 2006, please reconsider the above-identified U.S. patent application in light of the following remarks.